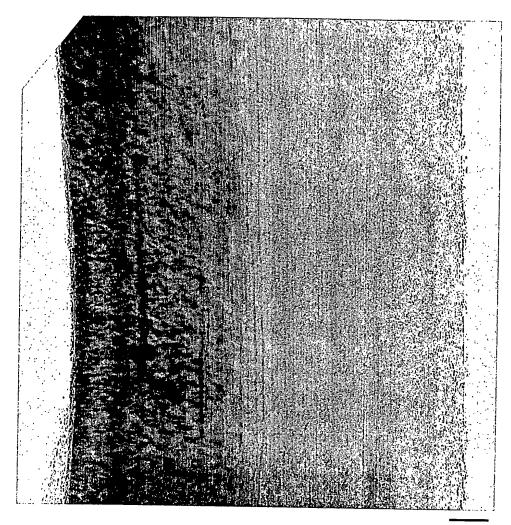
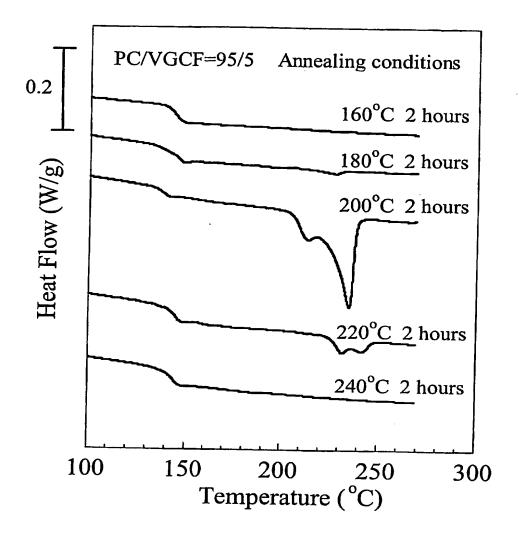
WO 2004/094520 PCT/JP2004/005895

Fig. 1



10nm

Fig. 2



WO 2004/094520 PCT/JP2004/005895

Fig. 3

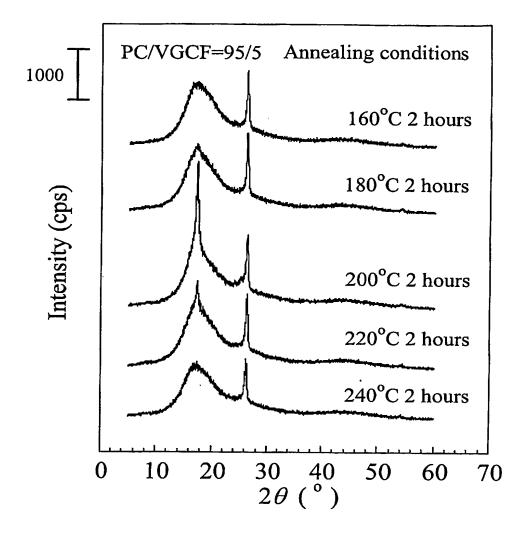


Fig. 4

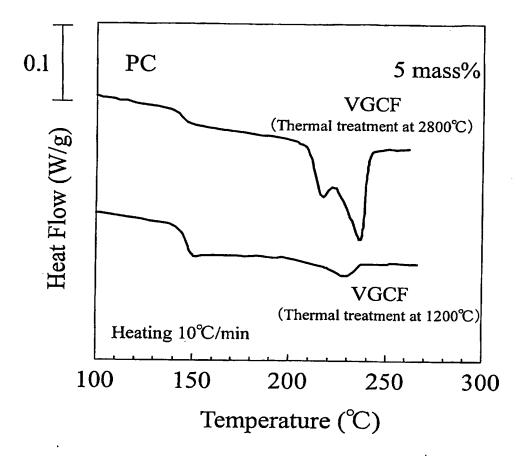


Fig. 5

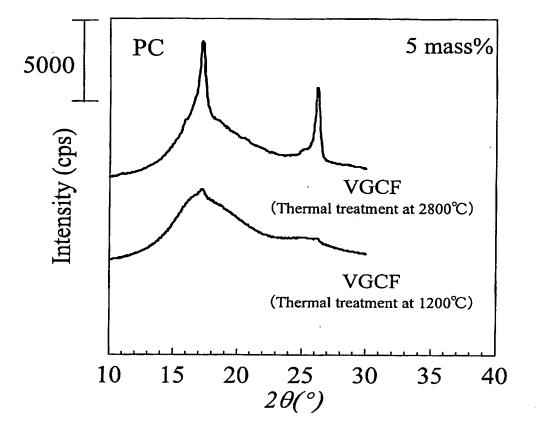


Fig. 6

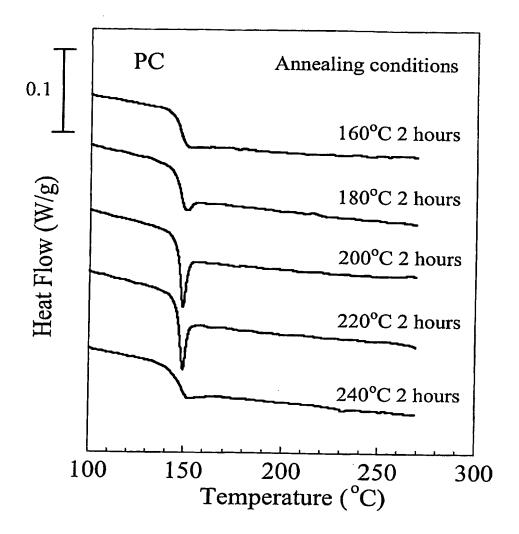


Fig. 7

